

PROCEEDINGS OF SPIE

***Plasmonics: Design, Materials,
Fabrication, Characterization,
and Applications XXI***

**Takuo Tanaka
Yu-Jung Lu**
Editors

**20–24 August 2023
San Diego, California, United States**

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Published by
SPIE

Volume 12648

Proceedings of SPIE 0277-786X, V. 12648

SPIE is an international society advancing an interdisciplinary approach to the science and application of light.

Plasmonics: Design, Materials, Fabrication, Characterization, and Applications XXI,
edited by Takuo Tanaka, Yu-Jung Lu, Proc. of SPIE Vol. 12648, 1264801
© 2023 SPIE · 0277-786X · doi: 10.1117/12.3013017

Proc. of SPIE Vol. 12648 1264801-1

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Please use the following format to cite material from these proceedings:
Author(s), "Title of Paper," in *Plasmonics: Design, Materials, Fabrication, Characterization, and Applications XXI*, edited by Takuo Tanaka, Yu-Jung Lu, Proc. of SPIE 12648, Seven-digit Article CID Number (DD/MM/YYYY); (DOI URL).

ISSN: 0277-786X
ISSN: 1996-756X (electronic)

ISBN: 9781510665101
ISBN: 9781510665118 (electronic)

Published by
SPIE
P.O. Box 10, Bellingham, Washington 98227-0010 USA
Telephone +1 360 676 3290 (Pacific Time)
SPIE.org
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